



Applicant: Hitoshi IRINO

Title: SEMICONDUCTOR
PROTECTION ELEMENT,
SEMICONDUCTOR DEVICE
AND METHOD FOR
MANUFACTURING SAME

Appl. No.: 10/796,999

Filing Date: 3/11/2004

Examiner: Lee, Calvin

Art Unit: 2818

**PETITION UNDER 37 CFR § 1.313(c)(2) TO WITHDRAW APPLICATION FROM
ISSUE**

Mail Stop Petition
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

1. Applicants hereby petition for the withdrawal of this application from issue.

PATENT ISSUE FEE

2. The issue fee for this case was paid on **January 21, 2006**.

REASON FOR WITHDRAWAL

3. Withdrawal from issue of the present application is requested in accordance with 37 C.F.R. § 1.313(c)(2) to reopen prosecution in favor of a Request for Continued Examination (RCE), submitted herewith, under 37 C.F.R. § 1.114.

PETITION FEES (37 C.F.R. § 1.17(i))

4. Attached is a check in the amount of \$920.00 for the Request for Continued

Examination (\$790.00), and the Petition fee (\$130.00). This amount is believed to be correct.

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130.00 OP

However, the Commissioner is hereby authorized to charge any deficiency (or credit any overpayment) to Deposit Account No. 19-0741.

Respectfully submitted,

Date January 30, 2006

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